RESPONSE UNDER 37 C.F.R. § 1.116 EXPEDITED PROCEDURE TECHNOLOGY CENTER 1700

03500.103115

PATENT APPLICATION

IN THE UNITED STATES PAT	ENT AND TRADEMARK OFFICE	
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In re Application of:)	-1/
Satoru Nishiuma	: Examiner: David G. Weisz)	7/10/09
Application No.: 10/553,870	: Group Art Unit: 1797)	ANES
Filed: October 21, 2005	: Confirmation No.: 1107	
For: OPTICAL ANALYSIS DEVICE	:) June 11, 2009	

Mail Stop AF

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

AMENDMENT AFTER FINAL REJECTION

Sir:

In response to the Office Action mailed March 11, 2009, please amend the above-identified application as follows.